

28/2



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q65781

Hiroyuki NAGASAWA

Appln. No.: 09/924,872

Group Art Unit: 2812

Confirmation No.: 3695

Examiner: Savitri MULPURI

Filed: August 09, 2001

For: SILICON CARBIDE AND METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 15, 2003, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS	7